

Search Notes



Application No.

10/692,721

Examiner

Jean F. Vollano

Applicant(s)

JAEHNE ET AL.

Art Unit

1621

SEARCHED

Class	Subclass	Date	Examiner
514	706	4/28/04	Jr
514	712		
568	38		
568	39		
568	41		
568	42		
568	44		
568	45		
568	51		
568	52		
564	305		
564	340		
562	41		
562	405		
562	400		
560			

560 30
560 40

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
CAPLUS BEILSTEIN EAST see inside	4/28/04	Jr
Unrevised search multiple co pending appl there is a potential ODP +		
with US 10/693102 However this is the only outstanding issue + it is the senior party so the Double patenting rejection was done in 10/693102 and thus application was allowed.		
Also there is US		
which contains subject matter but not a good date by the same applicant		
US 6,167,401 NO ODP		